

OK TO ENTER: /J.B./

09/21/2009

Reply under 37 C.F.R. 1.116  
Expedited Procedure  
Technology Center 2832

Confirmation No. 3317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DETECHEVERRY	Examiner:	Baisa, Joselito
Serial No.:	10/564,582	Group Art Unit:	2832
Filed:	January 12, 2006	Docket No.:	NL030878US (NXPS.267PA)
Title:	INDUCTIVE AND CAPACITIVE ELEMENTS FOR SEMICONDUCTOR TECHNOLOGIES WITH MINIMUM PATTERN DENSITY REQUIREMENTS		

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**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Customer No. <b>65913</b>
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Dear Sir:

In response to the Final Office Action dated July 22, 2009, please reconsider the application in view of the following remarks.

A complete Listing of the Claims and Remarks/Arguments follow.